

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Takahashi et al.  
Application No.: 10/525,443  
Filed: February 24, 2005  
For: **METAL SULFIDE THIN FILM AND METHOD FOR PREPARING  
THEREOF**

Confirmation No: 3864  
Group Art Unit: 1792  
Examiner: Elizabeth A. Burkhardt

Date: June 25, 2008

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Amendment and Response to Restriction Requirement**

Sir:

This is responsive to the Office Action mailed June 2, 2008 regarding the above-referenced patent application. Please amend this application as follows and consider the following remarks.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks** begin on page 4 of this paper.